

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

PATENT APPLICATION

Inventor: David Russell Evans

Serial No.: 09/270,606

Attorney Docket No.
SLA 587 (SMT 335)

Filed: March 17, 1999

Group No. 1765

Title: METHOD FOR
MODIFICATION OF
POLISHING
PATTERN
DEPENDENCE IN
CHEMICAL
MECHANICAL
POLISHING

Examiner: M. Anderson

FAX RECEIVED

SEP 20 2002

GROUP 1700

Box RCE
Hon. Commissioner for Patents
Washington, DC 20231

REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. § 1.114,
AMENDMENT AND REQUEST FOR RECONSIDERATION:

Sir:

This Request for Continued Examination is in response to
the Final Office Action dated March 20, 2001.

Please amend the above-identified application as follows: